

PATENT APPLICATION 110

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Saburo KAMIYA

Group Art Unit: 2877

Application No.: 09/661,433

Examiner: S. Turner

Filed: September 13, 2000

Docket No.: 107312

For: EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD IN WHICH POSITION OF REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS MEASURED (AS AMENDED)

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Siri

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

1. This Information Disclosure Statement is being filed more than three months after
HNSD1 0000000419561533ing date AND after the mailing date of the first Office Action on the merits,
but before the mailing date of a Final Rejection or Notice of Allowance.

a. Attached is our check no. 134091 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.

Respectfully submitted,

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MAC/ccs

Date: September 5, 2002

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